



PATENT
8017-1094

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Toshiji TAIJI et al.

Conf. 2404

Application No. 10/616,914

Group 1765

Filed July 11, 2003

Examiner L. Umez Eronini

SLURRY FOR CHEMICAL MECHANICAL POLISHING

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 31, 2005

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the cited documents are made of record on the enclosed PTO Form-1449.

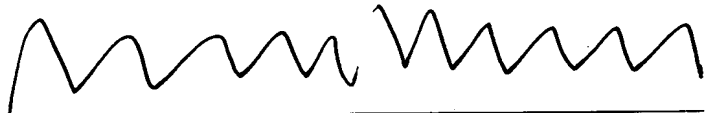
A concise explanation of the relevance of these items is that these references were cited in an Office Action dated May 31, 2005 in the corresponding Korean Application. A copy of the Official Action in which they were cited is attached hereto, with what is believed to be the pertinent portion enclosed in a wavy line. **An English translation of the Japanese enclosed portion is also attached hereto.**

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first

cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

A handwritten signature in black ink, appearing to read 'Robert J. Patch', written over a horizontal line.

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RJP/mjr
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* Abstract provided for the Examiner's convenience

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